

In re Patent Application of

KAJIMOTO et al.

Atty. Ref.: 900-481

Serial No. 10/716,661

TC/A.U.: 3723

Filed: November 20, 2003

Examiner: M. RACHUBA

For: METHOD OF MANUFACTURING SILICON WAFER

January 30, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **PETITION TO EXTEND**

Petition is hereby made to extend the life of the above-entitled application for three months from the due date of November 4, 2005, of the Official Action dated August 4, 2005.

An extension fee of \$1,020.00 is now attached in order that a CIP application may be filed herewith.

The Commissioner is hereby authorized to charge any <u>deficiency</u> in the fee(s) filed, or asserted to be filed, or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Account No. 14-1140. A duplicate copy of this sheet is attached.

01/31/2006 HALI11 00000079 10716661

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1020.00 OP

KAJIMOT et al. Serial No. 2716,661

Respectfully submitted,

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By:

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